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1. A light spot position sensor, comprising:

a substrate; and

a plurality of photosensitive devices arrayed at a certain pitch, formed with semiconductor layers deposited on said substrate, and isolated from each other.

- 2. The light spot position sensor according to claim 1, wherein said plurality of photosensitive devices configures a photosensitive device array arranged one-dimensionally.
- 3. The light spot position sensor according to claim 1, wherein said plurality of photosensitive devices includes a first photosensitive device array arranged on said substrate along a first axis; and

a second photosensitive device array arranged on said first photosensitive device array with an interlayer insulator therebetween, along a second axis different from said first axis.

- 4. The light spot position sensor according to claim 1, further comprising a scanning detector for sequentially scanning output signals from said plurality of photosensitive devices to detect a light spot position.
- 5. The light spot position sensor according to claim 1, further comprising:

an output signal line commonly connected to terminal electrodes of said plurality of photosensitive devices; and

a detection circuit connected to said output signal line,
wherein a light spot is radiated as a light pulse to determine
a light spot position from a delay time of a detection output

from said detection dircuit after said light pulse irradiation.

6. A displacement measuring device, comprising: a scale having scale markings formed along a measurement axis;

a sensor head movably arranged relative to said scale along said measurement axis for reading said scale markings; and

a state detection system mounted on said sensor head for optically detecting a relative positional state of said sensor head to said scale, wherein said state detection system contains a light spot position sensor including

a substrate; and

a plurality of photosensitive devices arrayed at a certain pitch, formed with semiconductor layers deposited on said substrate, and isolated from each other.

- 7. The displacement measuring device according to claim 6, wherein said plurality of photosensitive devices configures a photosensitive device array arranged one-dimensionally.
- 8. The displacement measuring device according to claim 6, wherein said plurality of photosensitive devices includes

a first photosensitive device array arranged on said substrate along a first axis; and

a second photosensitive device array arranged on said first photosensitive device array with an interlayer insulator therebetween, along a second axis different from said first axis.

9. The displacement measuring device according to

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claim 6, further comprising a scanning detector for sequentially scanning output signals from said plurality of photosensitive devices to detect a light spot position.

10. The displacement measuring device according to claim 6, further comprising:

an output signal line commonly connected to terminal electrodes of said plurality of photosensitive devices; and

a detection circuit connected to said output signal line, wherein a light spot is radiated as a light pulse to determine a light spot position from a delay time of a detection output from said detection circuit after said light pulse irradiation.

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- 11. The displacement measuring device according to claim 6, wherein said state detection system further includes a light source arranged on said sensor head for providing a light beam entering said light spot position sensor via said scale.
- 20 claim 6, wherein said state detection system further includes a state detection means for detecting at least one of a tilt, a gap and an original position of said sensor head to said scale based on a light spot position detected at said light spot position sensor.
 - 13. The displacement measuring device according to claim 11, wherein said light spot position sensor detects rotations in a parallel plane between said sensor head and said scale based on detection of interference fringes.
 - 14. A displacement measuring device, comprising:

a cantilever arranged opposite to a work to be measured and movable along a surface of said work without contacting said work;

a light spot position sensor mounted on the tip of said cantilever; and

a light source mounted on the tip of said cantilever for providing a light beam entering said light spot position sensor via said work, said light spot position sensor including

a substrate; and

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a plurality of photosensitive devices arrayed at a certain pitch, formed with semiconductor layers deposited on said substrate, and isolated from each other.

- 15. The displacement measuring device according to claim 14, wherein said plurality of photosensitive devices configures a photosensitive device array arranged one-dimensionally.
- 16. The displacement measuring device according to 20 claim 14, wherein said plurality of photosensitive devices includes

a first photosensitive device array arranged on said substrate along a first axis; and

a second photosensitive device array arranged on said first photosensitive device array with an interlayer insulator therebetween, along a second axis different from said first axis.

17. The displacement measuring device according to claim 14, further comprising a scanning detector for sequentially scanning output signals from said plurality of photosensitive devices to detect a light spot position.

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The displacement measuring device according to 18. claim 14, further comprising:

an output signal line commonly connected to terminal electrodes of said plurality of photosensitive devices; and

a detection circuit connected to said output signal line, wherein a light spot is radiated as a light pulse to determine a light spot position from a delay time of a detection output from said detection circuit after said light pulse irradiation.

- The displacement measuring device according to 19. claim 14, further comprising a detection means for detecting a surface feature of said work based on a position of said light beam detected at said light spot position sensor, said light beam output from said light source and entering said light spot position sensor via said work.
- The displacement measuring device according to 20. claim 14, further comprising:

20 a displacement device arranged on said cantilever for displacing the tip of said cantilever in the direction opposite to said work;

a displacement control means for feedback controlling said displacement device so that a position of said light beam detected at said light spot position sensor always comes to a constant position, said light beam output from said light source and entering said light spot position sensor via said work; and

a detection means for detecting a surface feature of said work based on a feedback signal from said displacement control means to said displacement device.

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21. The displacement measuring device according to claim 14, further comprising:

a displacement device arranged on said cantilever for displacing the tip of said cantilever in the torsion direction of said cantilever;

a displacement control means for feedback controlling said displacement device so that a position of said light beam detected at said light spot position sensor always comes to a constant position, said light beam output from said light source and entering said light spot position sensor via said work; and

a detection means for detecting a surface feature of said work based on a feedback signal from said displacement control means to said displacement device.

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